RESISTIVE MEMORY DEVICE WITH A TREATED INTERFACE

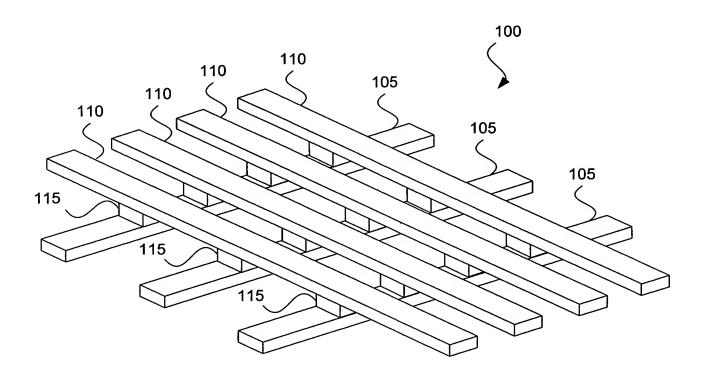


FIG. 1

RESISTIVE MEMORY DEVICE WITH A TREATED INTERFACE

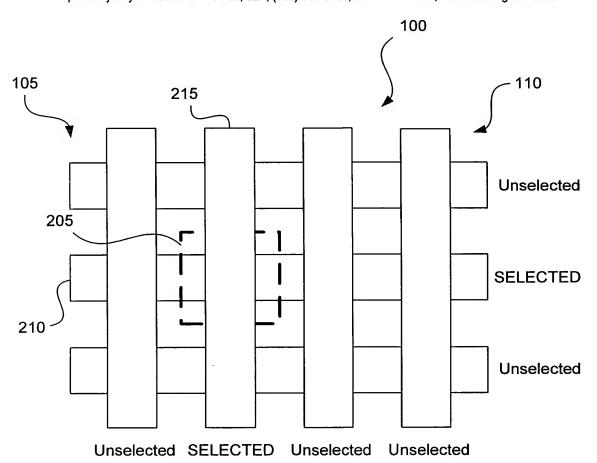


FIG. 2

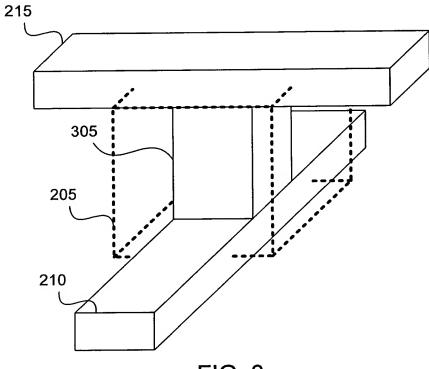


FIG. 3

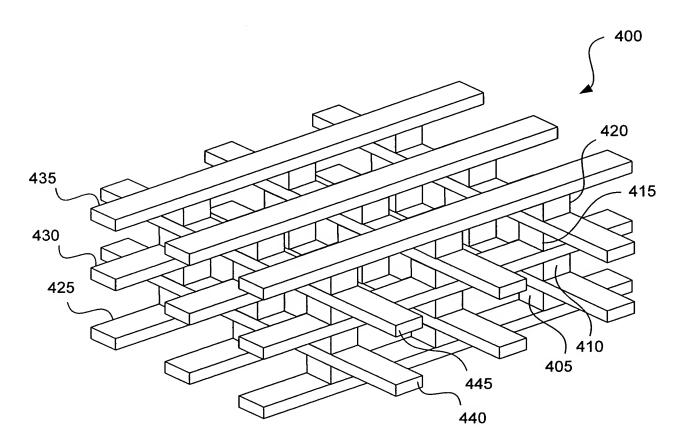


FIG. 4

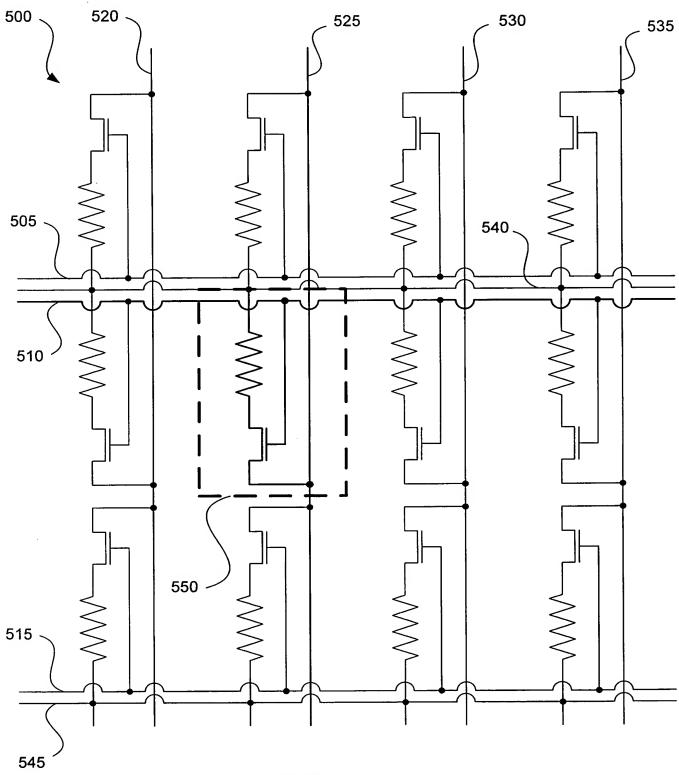


FIG. 5

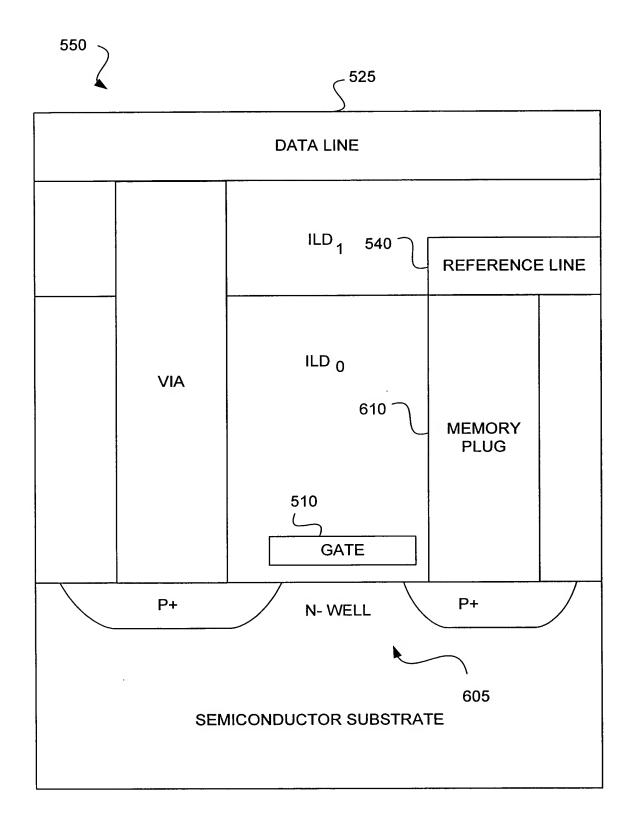
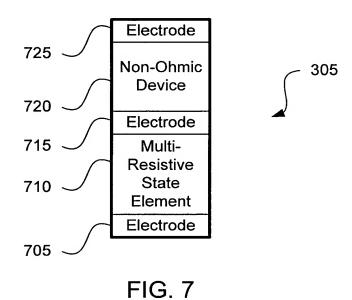


FIG. 6

RESISTIVE MEMORY DEVICE WITH A TREATED INTERFACE



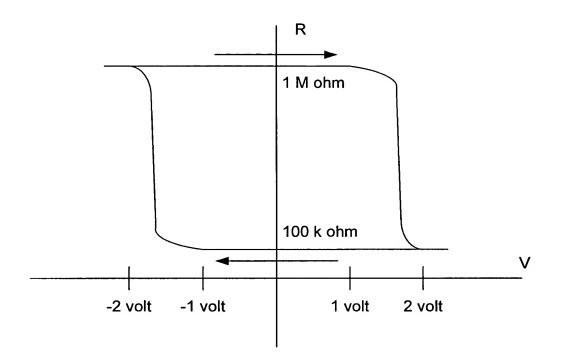


FIG. 8A

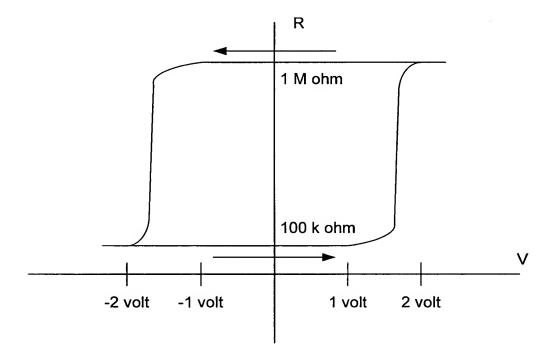


FIG. 8B

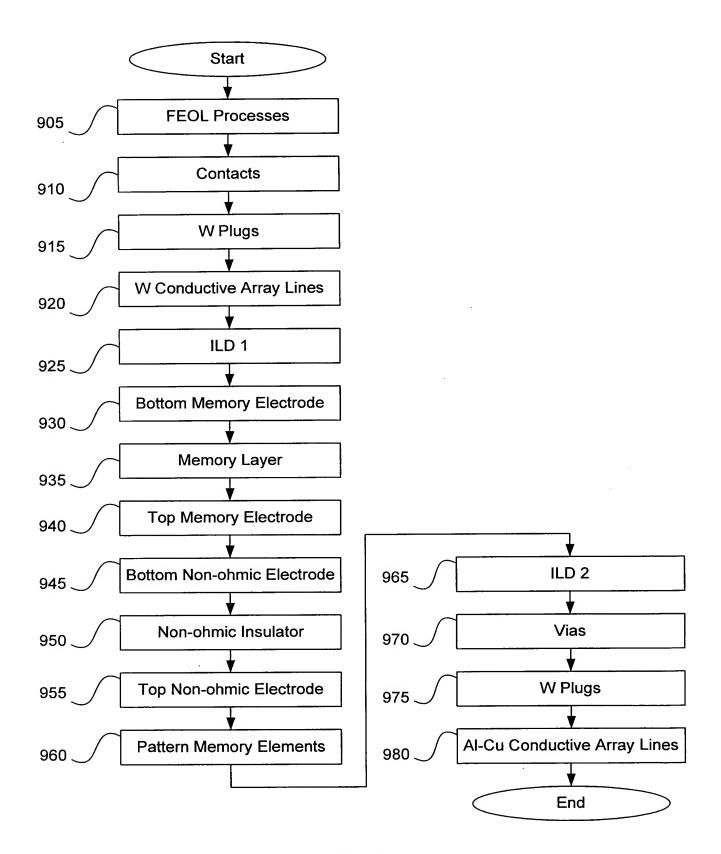
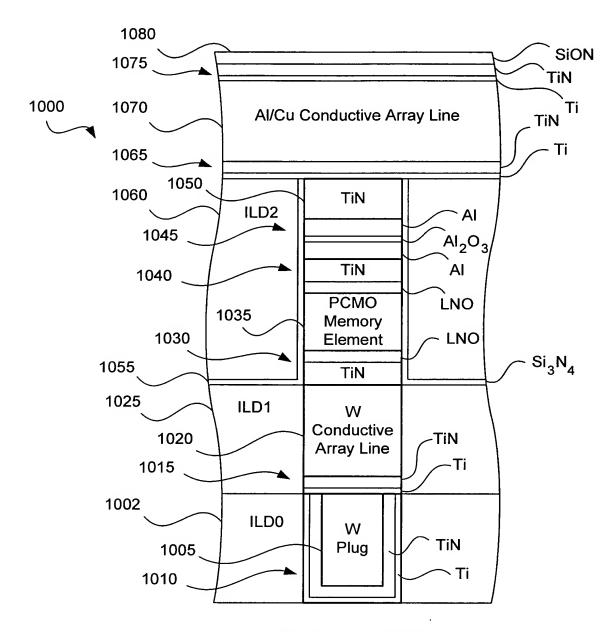


FIG. 9



Semiconductor Wafer

FIG. 10



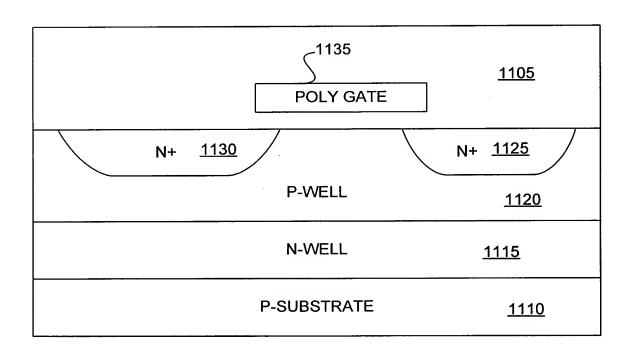


FIG. 11

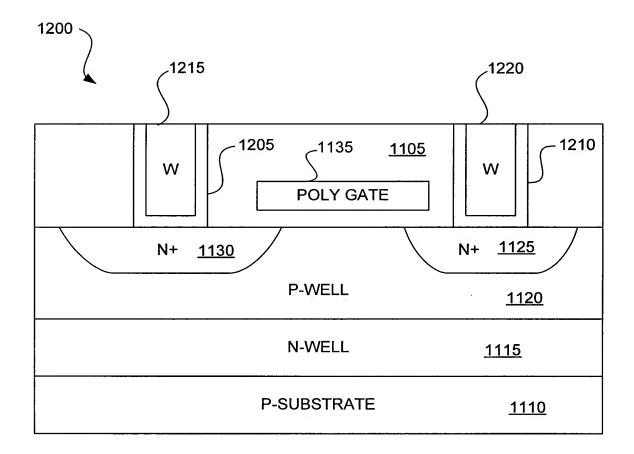


FIG. 12

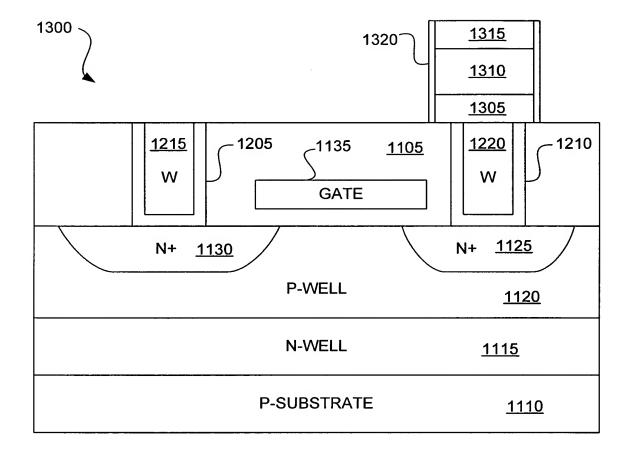


FIG. 13



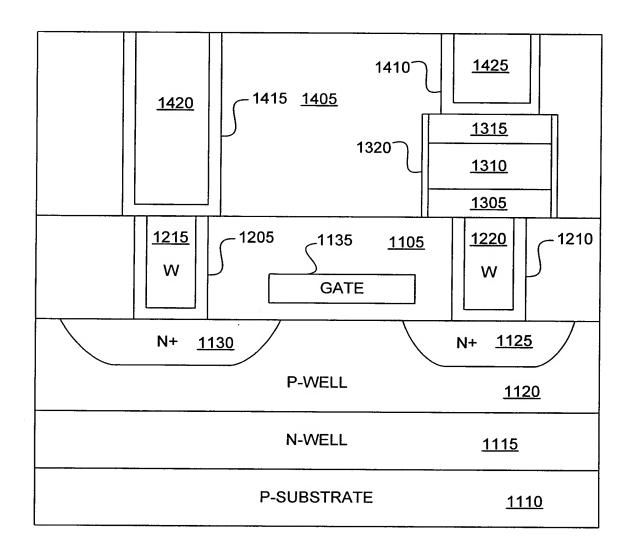


FIG. 14



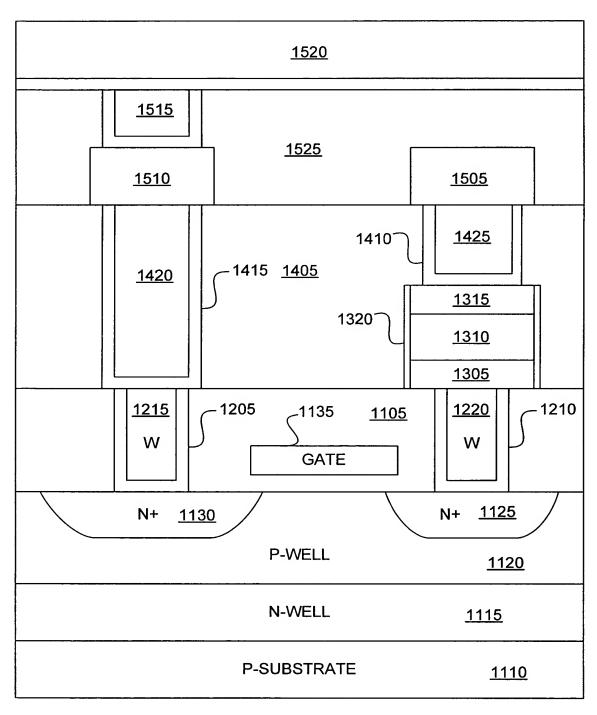


FIG. 15